

Substitute for form 1449A/PTO (modified)

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Page 1 of 3

Application Number

10/647523

Filing Date

August 25, 2003

First Named Inventor

Jing, Naiyong

Art Unit

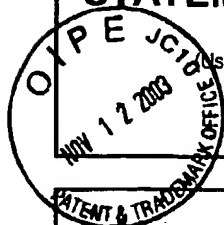
1773

Examiner Name

ZACHARIA

Attorney Case Number

56210US004



U.S. Patent Documents

Exam. Init.*	Cite No.	Document Number	Publication Date or Issue Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Doc. Number-(Kind Code if Known)			
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REZ	A2	US- 3,563,871	02/16/1971	Newman et al	
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REZ	A11	US- 4,824,692	04/25/1989	Gillick et al	
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		Doc. Number (Kind Code if Known)			
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Exam. Init.*	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published
REF	C1	Appl. Phys. Lett., Vol. 54, No. 1, January 2, 1989, ©1988 American Institute of Physics, "Ablation of Polytetrafluoroethylene (Teflon) with Femtosecond UV Excimer Laser Pulses", S. Küper and M. Stuke, p. 4-6.
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REF	C5	Dahm, R., in: "Surface Analysis and Pretreatment of Plastics and Metals", Applied Science Publishers, New York, 1982, p. 1-11

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	C9	Weismann, S.I.; <u>Journal Phys. Chem.</u>, 1954, Vol. 22, p. 1135
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REF	C16	Cooper, D.L.; Allan, N.L.; Powell, R.L.; <u>Journal Fluorine Chem.</u> , 1990, Vol. 49, p. 421
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REF	C24	<u>Semiconductor International</u> , 11, Burggraf, Pieter, No. 8, Vol. 5, (1988)
REF	C25	Related Application U.S. Serial No. 09/862,124, filed May 21, 2001, Attorney Docket No. 56211US002, now Publication No. 2002-0197481-A1
REF	C26	Related Application U.S. Serial No. 09/862,125, Filed May 21, 2001, Attorney Docket No. 56212US002, now allowed

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